

Inventor Information

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Application Information

Title Line One::	SCANNING EXPOSURE METHOD AND SYSTEM
Total Drawing Sheets::	28

Docket Number:: 108483

Prior Foreign Applications

Foreign Application One::	JP 2000-025661
Filing Date::	February 2, 2000
Country::	Japan
Priority Claimed::	yes
Foreign Application Two::	JP 2000-026630
Filing Date::	February 3, 2000
Country::	Japan
Priority Claimed::	yes